

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit: 1711

Serial No.: **10/576,193**

Examiner: **WALTERS JR, Robert S**

Filed: **April 17, 2006**

P.T.O. Confirmation No.: 8608

For: **METHOD OF FORMING LUSTER COATING FILM**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1711

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 20, 2010

Sir:

In response to the Office Action dated June 22, 2010, the period for response extended to October 22, 2010, by a one-month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.